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Docket No.: 050389-0052

PATENT

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : Customer Number: 20277  
Chihiro KAWAI, et al. : Confirmation Number: 3373  
Application No.: 10/500,975 : Group Art Unit: 2811  
Filed: July 08, 2004 : Examiner: Andrew O. Arena  
For: POROUS SEMICONDUCTOR AND METHOD FOR MANUFACTURING SAME

PETITION FOR EXTENSION OF TIME

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Commissioner for Patents  
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Sir:

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It is respectfully requested that the time for response to the Office Action dated April 1, 2008, now due to expire July 1, 2008, be extended for one month(s) and set to expire on August 1, 2008.

Please charge the extension fee of \$120.00 to Deposit Account No. 500417. Please charge any additional fees or credit any overpayment to Deposit Account No. 500417.

Respectfully submitted,

McDERMOTT WILL &amp; EMERY LLP

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